# Chemical Force Microscopy Research at the National Institute of Standards and Technology

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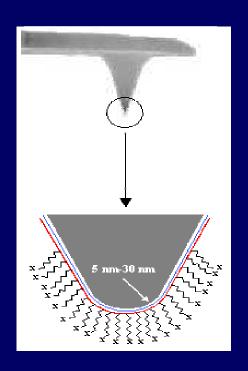
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# Chemical Force Microscopy (CFM)

C.D. Frisbie, L.F. Rozsnyai, A Noy, M.S. Wrighton, C.M. Lieber, 1994, *Science* 265:2071 A. Noy, D.V. Vezenov, and C.M. Lieber, *Annu. Rev. Mater. Sci*, 1997, 27:381



Au coated AFM
Probe, treated with
thiol SAM

Chemically Functionalized AFM probe with increased sensitivity to chemical differences:

- Tapping-Mode Phase imaging
- Friction Force Contact imaging

#### The promise of CFM:

nm scale chemical imaging of complex specimen surfaces

- Multiphase Polymers
- Biological Samples

#### **Barriers to a Better CFM:**

**Moving CFM beyond the demonstration stage:** 

- Characterization of probe functionalization
  - Quality and Reliability of SAM
- Relation of CFM contrast to traditional chemical analysis
- Lack of Challenging Model Specimens



# The NIST CFM Project:

Funded by the NIST Advanced Technology Program

# Highly Designed Reference Specimens

Polymers Division, MSEL

- Soft Lithography
- Self Assembly
- Gradient Approach

# **CFM**

## **Probe Characterization**

Optical Technology Division, PL

- Advanced Spectroscopy
  - Sum frequency generation
- Fluorescence Imaging
- Traditional and CNT probes

# **Contrast Enhancement Strategies**

Mat. & Bldg. Res. Div, BFRL

- Traditional and CNT Probe functionalization
- Humidity enhanced CFM contrast



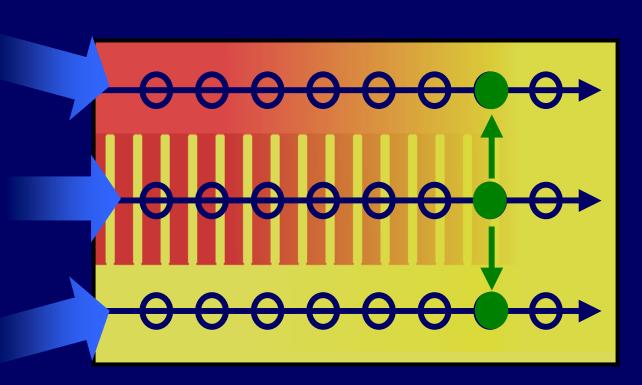


# Gradient Reference Specimen for CFM

Fasolka, Karim - Polymers Division, MSEL

Calibration area

μm scale pattern with decreasing contrast for CFM



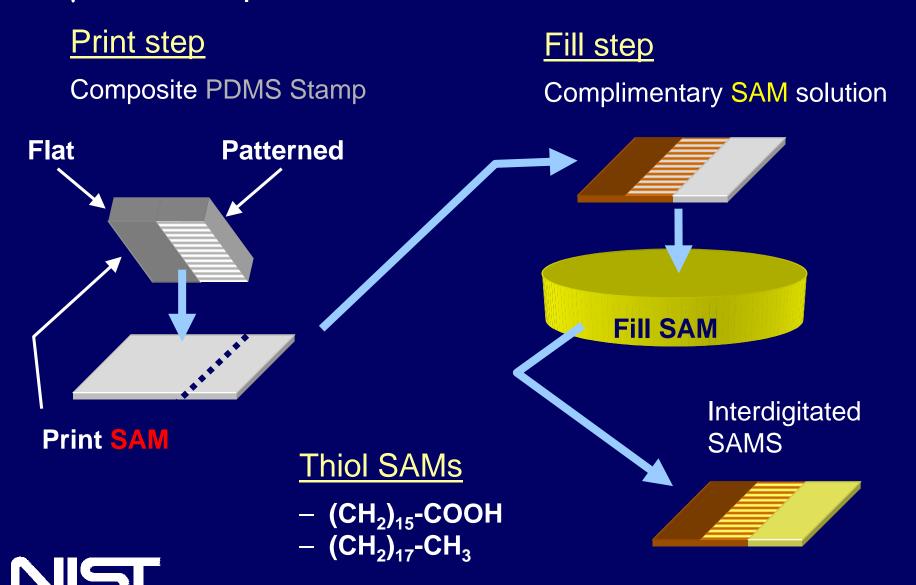
Calibration area

- Hydrophobic and Hydrophilic domains
- Illuminates chemical sensitivity (min. contrast)
- Relates contrast to traditional measurements (calibration) e.g. FTIR, contact angle
- "Gradually challenges" CFM technique



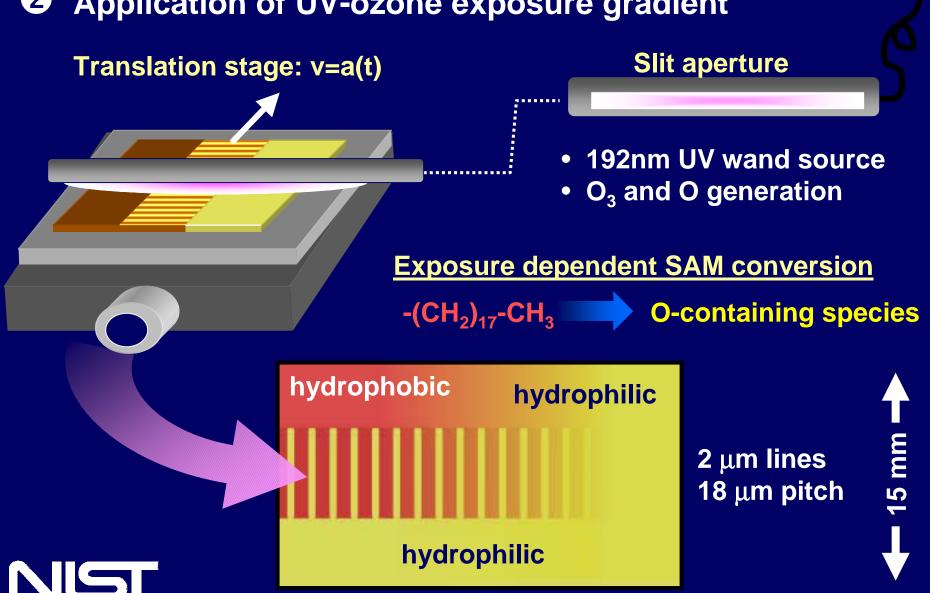
# Fabrication of Reference Specimen

μ-contact print thiol SAMs on Au substrate



# Fabrication of Reference Specimen

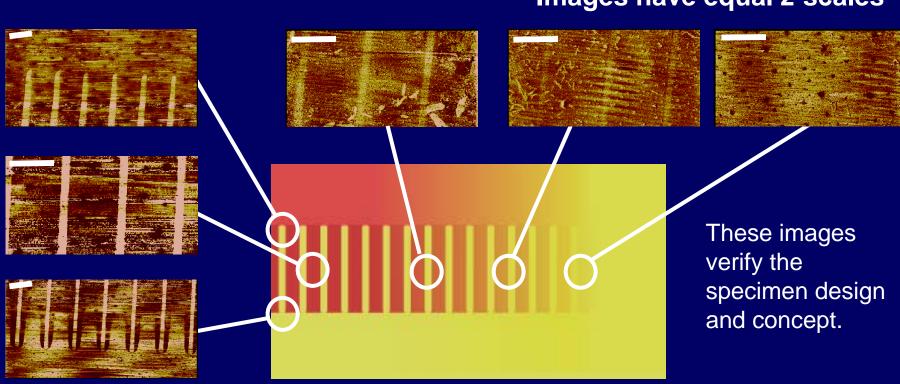
**Application of UV-ozone exposure gradient** 



# Gradient Reference Specimen Demonstration

**Contact-Mode Friction AFM Images** 

Scale bars are 10µm Images have equal z-scales



**Print:** CH<sub>3</sub> Terminated SAM

Fill: COOH Terminated SAM

**Linear Exposure Ramp: 0 - 60s** 



# Reference Specimen Characterization/Calibration

2.5x10<sup>-3</sup>

1.5 1.0

3050

3000

3000

2950

CH<sub>2</sub>

2950

2900

Vibrational Frequency / cm<sup>-1</sup> CH<sub>2</sub>

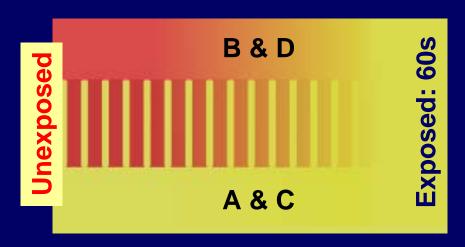
2900

Vibrational Frequency / cm

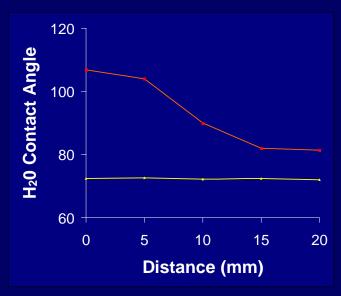
CH<sub>3</sub>

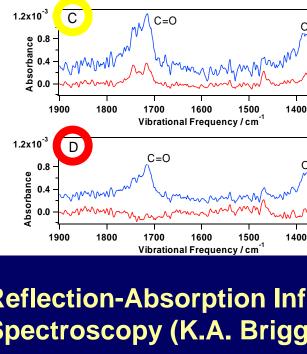
Absorbance

Absorbance



## **Water Contact Angle Measurements**







CH<sub>2</sub>

2850

CH<sub>2</sub>

2850

2800

2800

2750

2750

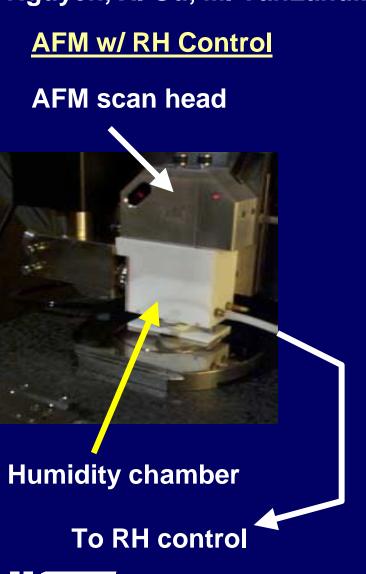
1300

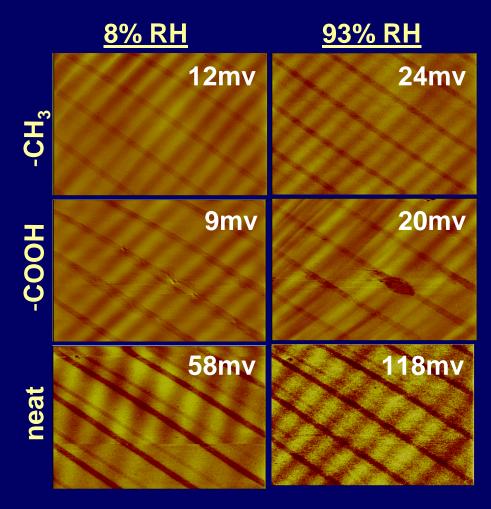
1300



# Relative Humidity (RH) Enhanced CFM Contrast

T. Nguyen, X. Gu, M. VanLandingham - BFRL





Friction CFM for three probe types -COOH Print, -CH<sub>3</sub> Fill, 18µm pitch



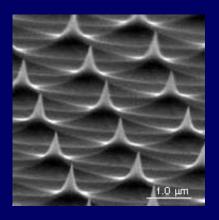
## **CFM Probe Characterization**



K.A. Briggman, J. Hwang – Physics Lab

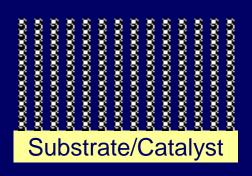
## Gauging the quality of probe functionalization

Ultrasharp tip arrays



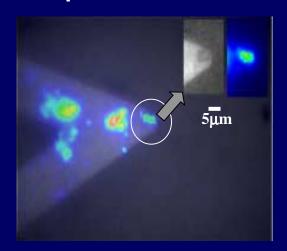
Silicon-MDT Ltd. www.siliconmdt.com

CVD-grown CNT Brush



**Prof. Eric A. Grulke**University of Kentucky

Fluorescence imaging of tip functionalization





### Surface-Sensitive IR Spectroscopies

- Reflection-absorption IR Spectroscopy
- Sum Frequency Generation Spectroscopy

## **Future Directions**



- Increasingly complex reference specimens
  - Chemical and Topographic Patterning
  - Block Copolymer Fracture Surfaces
- Refinement of RH-contrast enhancement
  - Stability improved, Mechanism Explored
- Further Development of Probe Characterization Methods
  - Probe-like array surfaces
  - Spectroscopic and Imaging Techniques

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